



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

June 27, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

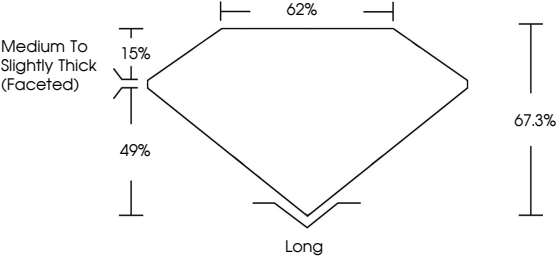
Fluorescence

Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

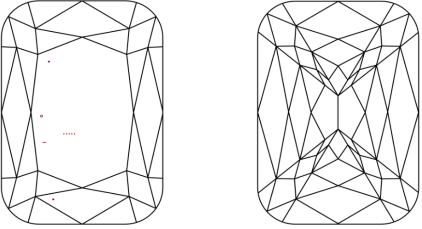
Report verification at igi.org

PROPORTIONS



Medium To Slightly Thick (Faceted)

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

Sample Image Used



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LABORATORY GROWN DIAMOND

RECTANGULAR CUSHION MIXED CUT

13.74 X 8.47 X 5.70 MM

6.20 CARATS

D

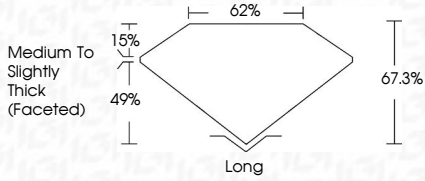
VS 1

EXCELLENT

EXCELLENT

NONE





Medium To Slightly Thick (Faceted)

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EXCELLENT

EXCELLENT

NONE





IGI

June 27, 2026

IGI Report No

RECTANGULAR CUSHION MIXED CUT

13.74 X 8.47 X 5.70 MM

Carat Weight

Color Grade

Clarity Grade

Table

Girdle

Medium to Slightly Thick (Faceted)

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

6.20 CARATS

D

VS 1

67.3%

62%

Long

EXCELLENT

EXCELLENT

NONE



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